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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

MIZUHARA et al.

Serial No.: 09/037,674

Filed: March 9, 1998

Atty. File No.: 2933SE-11-CIP-2

For: "SEMICONDUCTOR DEVICES
PASSIVATION FILM"Assistant Commissioner for Patents
Washington, D.C. 20231

Group Art Unit: 2811

Examiner: NADAV, O.

REPLY TO OFFICE ACTION
DATED FEBRUARY 23, 2001

CERTIFICATE OF MAILING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING
DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS
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ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON, DC
20231 ON May 22, 2001.

BY: Amy Quarto SHERIDAN ROSS P.C.

Dear Sir:

Applicant submits this Amendment and Response to address the Office Action having a mailing date of February 23, 2001. Although the Applicants believe that no fees are due for filing this Amendment and Response, please charge any fees deemed necessary to Deposit Account No. 19-1970. Reconsideration of the above-referenced application is respectfully requested in view of the following amendments and remarks.

Please amend the above-identified patent application as follows:

IN THE CLAIMS:

Please amend claims 25 and 31 as follows:

25. (Amended) A semiconductor device comprising:

a semiconductor substrate;

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